

Supplement 1

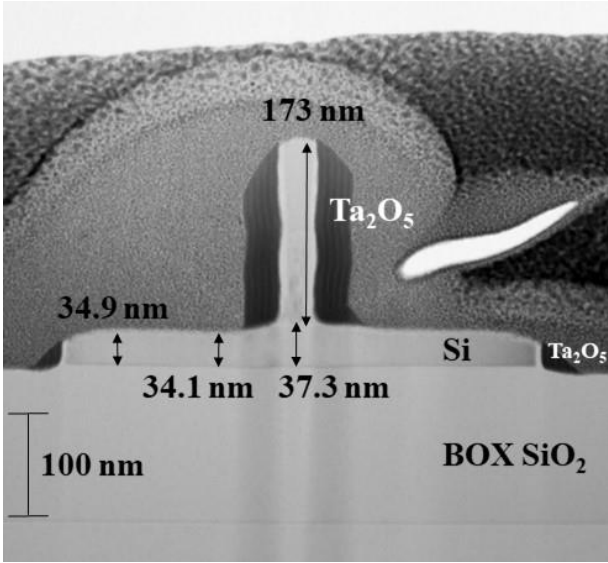


Figure 1: Illustration of a Ta₂O₅ topographically selective deposition (TSD) on sidewalls of a 3D structure.